

Notice of References Cited		Application/Control No. 10/675,140	Applicant(s)/Patent Under Reexamination GOEL ET AL.	
		Examiner DANIEL C. MCCRACKEN	Art Unit 1793	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0122754	09-2002	Ryzhkov, Vladislav Andeevitch	422/186.21
	B	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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	U	Prinzbach, et al., Gas-phase production and photoelectron spectroscopy of the smallest fullerene, C ₂₀ , Nature 2000; 407: 60-63		
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.